







Synchrotron and pion beam tests of 3D Medipix2 and TimePix Detectors

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- Introduction
 - 3D double sided detectors substrates
 - Medipix / Timepix description
- Micro-focussed X-ray beam
 - Set-up
 - Background subtraction
 - Efficiency and Charge Sharing
- Pion-beam from SPS
 - Set-up
 - Efficiency and Charge Sharing
- Conclusions





Medipix unit cell 55µm on the side Maximum drift length is 38.9µm

Pixel

Detectors are fabricated at Centro Nacional de Microelectronica, Barcelona Columns are etched from opposite sides of substrate Column fabrication

- » Reactive ion etching
- » Partial filing with polysilicon then doping



Radiation Hardness

Reduced Charge Sharing

Charge sharing in double-sided 3D Medipix2 detectors

D. Pennicard, et al. ,NIM A, Vol. 604, Issues 1-2, 1 June 2009, Pages 412-415



Medipix and Timepix





Medipix Timepix



- 65k single-photon counting pixel array
- Square pixel size of 55µm
- Electron or hole collection
- Threshold equalisation
- Count rate of ~100kHz
- Readout in 300 µs
- High dynamic range



X-ray Beamline Set-up



Compound refractive lens





- B16 Test beamline at the Diamond ۲
- Monochromatic X-ray beam of 14.5keV
- Beam size FWHM were measured as
 - 4.5±0.3 μ m in x
 - 6.7±0.3 μ m in y
- Six degrees of freedom, 0.1μ m translational and 5µrad rotational
- Alignment of 0.3° in x and 0.9° in y

Beam **3D detector** Detector substrate raster scanned relative to the beam





- 77.5μm square scans (55μm pixel)
- 2.5*µ*m steps
- Background subtracted

Pixel Maps

- Interpolated
- THL ~ 50% of beam energy

Planar



0.8

0.6

0.4

0.2





And Personal Property lies:

N-Type

Richard Bates, RD50, Nov 2009

0.8

0.6

0.4

0.2



Background Subtraction





- 1. Build up scan
- 2. Remove central pixel/ micro-focused beam.
- 3. Perform cross sections to estimate background in central pixel
- 4. Perform surface fit









*efficiencies at the corners due to electrodes structures and charge sharing



Charge Sharing







Charge Sharing



Double counting Planar: 0.5 photons	THL~25%			
3D: 0.25 photons <u>FWHM</u>	THL~50%	•		
Planar: ~12 <i>µ</i> m				
3D: ~8 <i>µ</i> m	THL~75%			
Reduced level of ove counting and under counting in 3D	er 1.6	→ THL~25% → THL~50% → THL~75%	1.6 THL~25% THL~50% THL~75% 1.2	1.6 ————————————————————————————————————
= Reduced Charge Sharing	nalised co			
Note : at 14.5keV – g worse for thicker Silicon & higher ene X-rays in Planar dev	yets $\sum_{0.6}^{0.8}$	P-Type 5 10 15 20 25	0.8 0.6 0.4 0.5 10 15 20 25	0.8 0.6 0.4 0.4 0.5 10 15 20 25 <i>µ</i> m





Medipix & LHCb

- Secondary 120 GeV pion beam from SPS
- 4 Timepix, 2 Medipix planes in telescope
- DUT: double sided 3D N-type sensor from CNM/Glasgow
- Expected track extrapolation error: < 3 μ m





Cluster width





- Fit to determine perpendicular position:
 -0.32 degrees
- Flat distribution in y
- Ratio ~1 at perpendicular







- Averaged result over all pixels
- Drop in efficiency at the electrode positions
- Here: efficient if hit in 3x3 pixel array around intercept point
- MIPs give a much higher efficiency than with x-rays due to track nature of charge deposition

Threshold just above noise level



Energy Spectra TOT Mode





•Same picture as before: Two column types have different signal size





 ADC counts (ToT) as function of distance from centre of cell





More landaus



- Just 1D plots of the columns of the plot on the previous slide
- Basically 2

 Landaus:
 MPVs are ~7
 and ~30
- Now for some explanation...





Signal explanation







Charge sharing









- Scans at different bias voltages
- Scans at different angles
- Scans with different thresholds
- Residuals





X-rays

- Pixels successfully mapped
- Efficiencies of the central electrode area found
 - 3 4% due to central electrode
 - Efficiency at corners equivalent to planar device
- Trade-off between efficiency and charge sharing
- Evidence of a decrease in charge sharing in 3D shown

MIPs

- Pion beam results complement X-ray characterisation
- Higher efficiencies shown
- TOT spectral evidence of charge sharing and efficiencies
- Trade off in between efficiency and radiation hardness





Thank you for your attention



Back-Up Lateral and Full depletion





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Back up Slides Background Subtraction



Planar



C41 After Background subtracted





P-Type











Back up Slides Background Subtraction









Wire scans and their derivatives



